



AVS Short Course offerings for May 18-21, 2020

- Basic Vacuum Technology
Monday - Thursday · May 18-21
- Evaporative Thin Film Deposition
Monday · May 18
- Cryopump Technology
Monday · May 18
- Plasma-Enhanced Chemical Vapor Deposition
Monday · May 18
- Fabrication of Planar Silicon CMOS Integrated Circuits
Tuesday · May 19 · (Half Day 8:30a-Noon)
- Plasma Etching and RIE: Fundamentals (Day 1) and
Applications (Day 2)
Tuesday &/or Wednesday · May 19-20
- Partial Pressure Analysis with Residual Gas Analyzers
Wednesday · May 20
- Contamination Control in Vacuum Systems
Thursday · May 21
- Vacuum Leak Detection
Thursday · May 21

Register today to be sure the course you want is available!

www.nmavs.org/short-courses

For questions about short courses, please contact:

David Adams · dadams205@comcast.net · 505-977-4547

Unless noted above, all short courses meet from 8:30 am - 4:30pm at the
Sheraton Albuquerque Airport Hotel · 2910 Yale Blvd SE · Albuquerque, NM 87106